

<b>Notice of References Cited</b>	Application/Control No. 10/621,513	Applicant(s)/Patent Under Reexamination CHIEN, TSENG-LU	
	Examiner Anabel M Ton	Art Unit 2875	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6,552,488	04-2003	Roitman et al.	313/512
	C	US-			
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**NON-PATENT DOCUMENTS**

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